	Application No.	Applicant(s)
	10/791,930	HSU ET AL.
Notice of Allowability	Examiner	Art Unit
	Alexander J. Kosowski	2125
The MAILING DATE of this communication appeared all claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RI of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in this ap or other appropriate communication IGHTS. This application is subject t	plication. If not included n will be mailed in due course. THIS
1. This communication is responsive to the AF filed 11/17/05.		
2. The allowed claim(s) is/are <u>1-4 and 6-20</u> .		
3. ☐ Acknowledgment is made of a claim for foreign priority ur a) ☐ All b) ☐ Some* c) ☐ None of the:		
1. Certified copies of the priority documents have been received.		
2. Certified copies of the priority documents have been received in Application No		
3. Copies of the certified copies of the priority documents have been received in this national stage application from the		
International Bureau (PCT Rule 17.2(a)).		
* Certified copies not received:		
Applicant has THREE MONTHS FROM THE "MAILING DATE" of this communication to file a reply complying with the requirements noted below. Failure to timely comply will result in ABANDONMENT of this application. THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		
4. A SUBSTITUTE OATH OR DECLARATION must be submitted. Note the attached EXAMINER'S AMENDMENT or NOTICE OF INFORMAL PATENT APPLICATION (PTO-152) which gives reason(s) why the oath or declaration is deficient.		
5. CORRECTED DRAWINGS (as "replacement sheets") must be submitted.		
(a) ☐ including changes required by the Notice of Draftsperson's Patent Drawing Review (PTO-948) attached		
1) 🗌 hereto or 2) 🔲 to Paper No./Mail Date		
(b) including changes required by the attached Examiner's Amendment / Comment or in the Office action of Paper No./Mail Date		
Identifying indicia such as the application number (see 37 CFR 1.84(c)) should be written on the drawings in the front (not the back) of each sheet. Replacement sheet(s) should be labeled as such in the header according to 37 CFR 1.121(d).		
6. DEPOSIT OF and/or INFORMATION about the deposit of BIOLOGICAL MATERIAL must be submitted. Note the attached Examiner's comment regarding REQUIREMENT FOR THE DEPOSIT OF BIOLOGICAL MATERIAL.		
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Attachment(s)	_	
1. ☑ Notice of References Cited (PTO-892)	,	Patent Application (PTO-152)
2. Notice of Draftperson's Patent Drawing Review (PTO-948)	6. 🔀 Interview Summary Paper No./Mail Da	(PTO-413),
3. Information Disclosure Statements (PTO-1449 or PTO/SB/0	8), 7. 🛭 Examiner's Amend	ment/Comment
Paper No./Mail Date 4.	8. Examiner's Statement	ent of Reasons for Allowance
or biological material	9. Other	

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DETAILED ACTION

1) Claims 1-4 and 6-20 are presented for examination.

EXAMINER'S AMENDMENT

2) An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

Authorization for this examiner's amendment was given in a telephone interview with Timothy Bliss on 12/19/05.

The application has been amended as follows:

Please cancel claims 19-20.

Referring to claim 1, line 2, please change "operation of a product" to read --operation of a semiconductor product--.

Allowable Subject Matter

3) Claims 1-4 and 6-18 are allowed.

Referring to claim 1, Allen, alone or in combination with the prior art of record, does not explicitly teach a method for preventing contamination during a manufacturing operation of a semiconductor product comprising comparing a product contributive attribute and an operation acceptance attribute prior to performing an operation on a product, wherein the operation acceptance attribute identifies contaminants unacceptable to the operation, and suspending the operation if the product and operation are not compatible, in combination with the remaining elements or features of the claimed invention

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Referring to claims 12 and 14, Allen, alone or in combination with the prior art of record, does not explicitly teach a method for preventing contamination during a substrate manufacturing operation comprising determining if a substrate routing attribute associated with the substrate corresponds to an operation contributive element associated with the operation, wherein the substrate routing attribute indicates a material not acceptable to the substrate, wherein the operation contributive attribute indicates a material used in the operation, and utilizing the correspondence to determine if the operation should be suspended, in combination with the remaining elements or features of the claimed invention.

Referring to all other claims, the claims are dependent on the allowable claims above, and are therefore also allowable.

Conclusion

- 4) Although not utilized in previous office actions, Examiner wishes to add related art to the record. This art has been noted on the attached PTO-892.
- Any inquiry concerning this communication or earlier communications from the examiner should be directed to Alexander J Kosowski whose telephone number is 571-272-3744. The examiner can normally be reached on Monday through Friday, alternating Fridays.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Leo Picard can be reached on 571-272-3749. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300. In addition, the examiner's RightFAX number is 571-273-3744.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is 571-272-2100.

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Alexander J. Kosowski Patent Examiner Art Unit 2125 LP Bil

LEO PICARD SUPERVISORY PATENT EXAMINER TECHNOLOGY CENTER 2100